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Description

Rewiring substrate strip with several semiconductor component positions

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The invention relates to a rewiring substrate strip with several semiconductor component positions and semiconductor components of the rewiring substrate strip, which are arranged in rows and columns on the rewiring substrate strip, and to a method for producing these.

For semiconductor components, it is increasingly aimed at minimizing the product package size produced. For this purpose, the number of outside contacts is reduced 15 to a minimum and it is attempted to avoid as many semiconductor component, outside contacts of a previously provided for test optimization purposes and analysis purposes, as possible. Such a reduction in outside contacts is associated with the disadvantage 20 that outside contacts for internal test and analysis purposes are no longer provided externally on the package. Although this results in small product packages, at the same time this also disadvantageously 25 results in significant restrictions in the analysis and testability of such semiconductor components and their intermediate product stages.

The associated risks with respect to the yield of 30 operable semiconductor components from a rewiring strip cannot be compounded by further substrate improved production methods. The art thus distinguishes between a product package which has the minimum required number of external contacts, and a so-called debugging package, the debugging package 35 additional removable test contacts which, after a test separated from operability, are the production package.

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If in addition to the external contacts of the product package, test areas are provided on a debugging component which is larger than the product component, a variety of possibilities for testing the component are obtained by adding test contact surfaces in edge areas of the debugging component. However, this creates an increased requirement of surface with the increasing number of test surfaces between the semiconductor components of a component group of a rewiring substrate strip.

It is an object of the invention to create a rewiring of strip with a number semiconductor substrate component positions by means of which the problems can be overcome. In this context, an analysis testability of internal signals for optimization, for correlation with other package shapes and for characterizing the semiconductor components should be retained in spite of the reduced number of 20 external contacts and reduced package Furthermore, an optimized arrangement and alignment of semiconductor components in the semiconductor component positions should be created which provide for reduced product package size and optimized size debugging components. Finally, tests without damage to or deformation of external contacts should become possible. In addition, it is an object of the invention specify а simple and inexpensive solution electrical contact arrangements mechanical and semiconductor components or of semiconductor modules of a large package scale integrated circuit for a "burnin" test.

This object is achieved by means of the subject matter 35 of the independent claims. Advantageous developments of the invention are found in the dependent claims.

According to the invention, a rewiring substrate strip several semiconductor component positions semiconductor components is created and a method for producing it is specified. The semiconductor components are arranged in several component rows and component columns, subdivided by cutting lines, on the rewiring substrate strip. For this purpose, semiconductor component positions are combined to form one component group. The semiconductor component group several semiconductor chips comprises semiconductor components on a top side of the rewiring substrate strip. Within a component group, cutting strips, which are bounded by cutting lines and comprise the test contact surfaces are provided between the component rows and component columns.

The semiconductor component positions including their test contact surfaces are aligned with respect to one another in such a manner that a parquetting pattern parallel-rod parquett pattern according to a produced. The arrangements of external contacts and test contact surfaces of the semiconductor components are arranged and aligned with respect to one another in accordance with the parquetting pattern in such manner that four next neighbors of a semiconductor component comprise an arrangement of the contacts which is aligned rotated by uniformly  $90^{\circ}$  or by uniformly 270° with respect to the arrangement of the individual semiconductor component.

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The rewiring substrate strip has the advantage that the surface to be provided for a component group is optimized in such a manner that as many test contact surfaces as possible can be provided in corresponding cutting strip sections for each of the component positions. Furthermore, the alignment of the four next neighbors of a semiconductor chip rotated by uniformly 90° or uniformly 270° with respect to the semiconductor

chip has the result that the connecting lines between external contacts and test surfaces can be optimized in length and density.

Such connecting lines between external contacts of the 5 product package and test contact surfaces of debugging package can be advantageously implemented both on the top side of the rewiring substrate strip and on the rear side of the rewiring substrate strip in 10 form of rewiring lines. The rear advantageously selected when the test is to be done on the side of the external contacts, and the top side is used for the rewiring lines and for the test contact surfaces if the testing is to take place on the top 15 opposite to the external contacts, of rewiring substrate strip on which the semiconductor chips are also located. The uniformly rotated alignment of four next neighbors with respect to a semiconductor chip also has the advantage that when the top side of 20 rewiring substrate strip is equipped semiconductor chips, the automatic insertion machine only has to perform two alignments of the semiconductor chips rotated by a fixed angle with respect to one another, or only two predetermined alignments of the 25 semiconductor chips by the automatic insertion machine of a correspondingly prepared semiconductor wafer or a correspondingly prepared intermediate carrier or of a correspondingly prepared conveyor belt have accommodated.

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In a further embodiment of the invention, component rows and component columns of a component group comprise first and second semiconductor chips. In this arrangement, the first and second semiconductor chips differ in their alignments. The first semiconductor chips have a first alignment A whereas the second semiconductor chips uniformly have an alignment B which is rotated either by 90° or uniformly by 270° with

respect to the first alignment A. The first and second semiconductor chips are then alternately arranged in the component rows and component columns.

- 5 Thus, e.q. each odd-number semiconductor position in the component rows and component columns of a component group can advantageously have the alignment Correspondingly, the even-number semiconductor component positions in the component rows and component columns of a component group then have the alignment B. 10 is associated with the advantage that arrangement of the external contacts on the rear side of the semiconductor chip is aligned in exactly the same manner as the semiconductor chips on the top side 15 of the rewiring substrate strip which advantageously simplifies the rewiring structure within the rewiring substrate strip and/or on its top side and its rear side.
- In a preferred embodiment of the invention, external contact patches having external contact in the semiconductor positions are arranged on a rear side of the rewiring substrate strip opposite to the top side. These external contact patches belong to a rewiring structure which has rewiring lines. These rewiring lines of the rewiring structure connect the external contact patches to the test contact surfaces on the cutting strips of the rewiring substrate strip.
- This embodiment of the invention has the advantage that the rewiring substrate strip can be produced relatively inexpensively, especially since it only needs a rewiring structure with rewiring line to the test contact surfaces on its rear side on which the external contact patches are to be provided, in any case. Correspondingly, only those metallic structures which enable the rewiring substrate strip to be connected to the semiconductor chips in each of the semiconductor

component positions are necessary on the top side of substrate strip, plated-through rewiring and contacts to the external contact patches on the rear side of the rewiring substrate strip are required. Thus, both the rear side and the top side of the substrate strip can be patterned with rewiring conventional technologies also known from circuit board production, which reduces the costs for the rewiring substrate strip.

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In a further preferred embodiment of the invention, the respective semiconductor component positions are associated with cutting strip sections which carry the test contact surfaces and are arranged on two opposite edges of the product package. This is associated with the advantage that a rectangular debugging package is produced for a product package with outline, which forms the basis for a parallel-rod Parquet pattern. In this pattern, intersection areas are created which are formed by the intersection of horizontal and vertical cutting strips along the component rows and the component columns.

further embodiment of the invention, Ιn 25 intersection areas can also be used for arranging test contact surfaces for optimum utilization of the surface of a component group. For this purpose, a quarter of these test contact surfaces on an intersection area is in each case allocated to one of the four adjoining semiconductor component positions. This advantageously 30 increases the possible number of test contact surfaces per semiconductor component position, especially since, according to the parketting pattern, four intersection areas adjoin one semiconductor position which increases the surface of the semiconductor positions which can be 35 for test contact surfaces by one entire intersection area per component position.

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It is also provided that a number of component groups are arranged in a row behind one another and/or next to another on the rewiring substrate strip more plastic covers. preferably have one or plastic covers are required, in particular, electrical connections between semiconductor chip and rewiring substrate strips are produced by means of bonding technology and thus by means of sensitive bonding wires. These plastic covers on the component groups safequard and protect such bonding wires of the bonding connections between semiconductor chip rewiring substrate strip.

Another possible connection between semiconductor chip and rewiring substrate strip is possible by means of the so-called flip-chip technology. For this purpose, surfaces on the active top side of contact semiconductor chip, which are otherwise available for connections, are provided with flip-chip bonding be soldered directly contacts which can corresponding contact pads on the rewiring substrate strip. Since a relatively stable soldering connection is achieved in this embodiment of the invention via the flip-chip contacts between the semiconductor chip and the rewiring substrate strip with corresponding contact pads, packages without protective plastic cover also possible in this embodiment of the invention.

further embodiment of the invention, provided that the rewiring substrate strip has on its rear side, outside the area of a component group, areas with exposed test contact surfaces. These test contact surfaces are electrically connected to the test contact surfaces in the cutting strips and/or the external contact patches of the semiconductor components and/or active side of contact areas on the semiconductor chips via rewiring lines. This embodiment of the invention has the advantage that measurements

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and tests previously not provided can be additionally performed on the rewiring substrate strip via these additional test contact surfaces outside the component groups. Whilst the surface of a component group is optimized and minimized, the rewiring substrate strip has sufficiently large surfaces outside a component group for providing such additional test contact surfaces. This makes it possible advantageously to expand the analyses and tests of the individual integrated circuits.

A further improvement of the testing capabilities for the rewiring substrate strip consists in that in the edge area of the rewiring substrate strip, a test contact strip is provided for a component group for a temperature cycle test or, respectively, "burn-in" test. For this so-called "burn-in" test, characteristic semiconductor component elements on the semiconductor chip are connected to the plug-in contact strip via a bunch of corresponding rewiring lines so that it is not necessary to prepare individual components for "burn-out" test but these temperature cycle tests can groups performed for entire component rewiring substrate strip. Such a plug-in contact strip can be arranged both on the rear side and on the top substrate strip. In of the rewiring arrangement, the individual plug-in contact surfaces of a plug-in contact strip can be electrically connected to the test contact surfaces and/or the external contact patches and/or the contact areas of an active top side of a semiconductor chip. In addition, other rewiring lines can be connected to the plug-in contact strip in order to perform additional functional tests individual semiconductor components semiconductor component group via the plug-in contact strip.

Instead of providing for contacting via the plug-in contact strip, the test contact surfaces can also be connected either directly to corresponding test probes, or test contacts are applied to the test surfaces. Such applied test contacts have the advantage that the test probes, in the form of measuring tips, do not need to be applied to the external contacts or to the test contact surfaces of a product package or, respectively a debugging package. The external contacts of a product package or, respectively, the test contact surfaces of a debugging package are thus neither contaminated by the measuring tips nor are measuring tips conversely contaminated by the external contacts or, respectively, the test contact surfaces.

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To further reduce the risk of contamination of the measuring tips by test contact surfaces or test contacts, test contact surfaces or test contacts can be covered with gold plating in a further embodiment of the invention. Such gold plating of the test contact surfaces or of the test contacts also improves the contact resistance of the contact, especially since gold does not oxidize in air like aluminum or copper or is sulfidized in air like silver.

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embodiment of the invention makes it further Α possible, especially by providing debugging packages with a correspondingly high number of test contact surfaces, to test rewiring substrate strips with a stack of a logic chip and a memory chip in the semiconductor component positions. In this context, both the memory functions of the memory chip and the logic functions of the logic chip can be tested via the test surfaces and/or the exposed test surfaces and/or via the plug-in contact strips even before the rewiring substrate strip is packaged and processed further to form individual semiconductor components.

Semiconductor components which have been produced on the basis of such rewiring substrate strips can easily identified, especially since they have on opposite edges of their package cut rewiring which lead to the test contact surfaces on the cutting strips of the rewiring substrate after they have been separated to form semiconductor components. Such semiconductor component has the advantage that it can still be intensively tested before encapsulation coverage by means of a plastic compound so that it is either possible to identify and remove defective semiconductor chips before the packaging, or to retain the defective semiconductor chips but to mark them in such a manner that they can still be recognized and sorted out after they have been separated into individual semiconductor components.

A method for producing a rewiring substrate strip with several component groups which comprise semiconductor component positions with semiconductor chips, arranged in component rows in the x direction and in component columns in the y direction, comprises the following method steps.

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Firstly, a substrate strip is provided which is metalplated at least on its rear side. This metal plating is patterned to form a rewiring structure which comprises external contact patches in the semiconductor component positions and test contact surfaces in the area of cutting strips between the semiconductor component positions. Once such a rewiring structure has been produced, semiconductor chips are mounted in accordance with a predetermined plan on the top side of the First, strip. each odd-numbered rewiring substrate semiconductor component position in the component rows and the component columns is equipped with a first semiconductor chip in a first alignment A.

Following that, the remaining even-numbered conductor positions in the component columns component rows are equipped with a second semiconductor chip, the second semiconductor chips uniformly having an alignment B rotated by 90° or uniformly having an alignment B rotated by 270° with respect to the first In this arrangement, both the alignment A. semiconductor chips and second semiconductor chips can have completely identical integrated circuits. first alignment A and the second alignment B have the that a rod-Parquet pattern is formed accordance with a predetermined plan the xdirection.

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Following this, connections are produced between the semiconductor chips and the rewiring structure. After that, external contacts in the semiconductor component positions are applied to the external contact patches of the rewiring structure on the rear side of followed rewiring substrate strip. This is functional tests of the semiconductor chips of the semiconductor components with contacting of the test contact surfaces and/or of test contact surfaces and/or of plug-in contact surfaces of a plug-in contact strip. Finally, the defective semiconductor components on the rewiring substrate strip are marked.

method has the advantage that, due to additional test contact surfaces on the cutting strips 30 in the component groups and the additional plug-in contact surfaces on edges of the rewiring substrate strip, functional tests of the semiconductor chips can be performed completely and in an improved having to contact 35 the without, however, contacts on the rewiring substrate strip. In addition, this method has the advantage that the internal signal processing in the semiconductor chips arranged in

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component groups can also be tested without requiring additional external contacts for the product package.

In consequence, using this method, components can be produced which have packages with reduced size, whilst at the same time reducing the number of external contacts, and which, nevertheless, can be subjected to a complete and improved functional test even for the internal signal processing. By arranging the plug-in contact strip, a "burn-in" test cycle method can also be performed directly with the aid of the rewiring substrate strip. The semiconductor components can thus be tested under extreme temperature cycle loading even groups the component are separated into individual semiconductor components.

In this method according to the invention, these advantages, namely the gentle treatment of the external contacts of the product package, the extended testing and analysis capability of internal signal variations of all semiconductor chips and the testing of each of semiconductor with а number group component components within, for example, a plastic cover under extreme temperature fluctuations, become possible by the parketting pattern of the means of substrate strip according to the invention. When the semiconductor components are separated, the cutting strips with their test surfaces are cut out so that the product package remains small since the test contacts jointly removed from the so-called debugging package.

A further variant of the method provides for the semiconductor chips to be mounted uniformly and with standard alignment on the top side of the rewiring substrate strip. For the rewiring structure, however, it is provided on the rewiring substrate strip that in the semiconductor component positions of the rewiring

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substrate strip, an alignment of the arrangement of compared with the alignment contacts semiconductor chips in the component rows and component odd-numbered semiconductor for component positions is provided uniformly rotated by 0° and/or 180° and for even-numbered semiconductor component positions in the component rows and the component columns rotated uniformly by 90° and/or uniformly by 270° with respect to the alignment of the semiconductor chips.

Thus, the different predetermined rotation in the evennumbered and the odd-numbered semiconductor component positions is carried out by means of a predetermined rewiring plan for a multi-layered rewiring substrate strip, preventing semiconductor chips from twisted. This means that, although the multi-layered rewiring substrate strip has a more complex structure especially since it implements the required difference in rotation of arrangements of external contacts via correspondingly patterned rewiring lines and throughhole plated contacts, the advantage consists in that the equipping of the rewiring substrate strip in the component groups is simplified, especially since the semiconductor chips of a component group can remain uniformly aligned.

In a further variant of the performance of the method, a wafer separated into semiconductor chips is available differently aligned and arranged mounting semiconductor chips on a rewiring substrate strip. This comprises semiconductor chips aligned wafer xarranged in preparatory manner in and yarrangement and in rotational alignment. mounted on the top side of the rewiring substrate strip in the predetermined arrangement and alignment of the wafer by an automatic insertion machine.

This method with a semiconductor wafer already prepared applied to the top side of a substrate strip has the advantage that the equipping of the rewiring substrate strip with semiconductor chips with different alignments can be performed without additional rotation by means of a standard automatic insertion machine in the component positions component group. The same advantage is obtained if in another variant of the performance of the method, a foil with semiconductor chips in a flat arrangement or a conveyor belt with linearly arranged semiconductor chips is available which comprise semiconductor chips aligned and arranged in a preparatory manner in x-, yand/or in rotational alignment. arrangement semiconductor chips can also be mounted on the top side of the rewiring substrate strip in the predetermined arrangement and alignment by means of a standard automatic insertion machine from such a foil or such a conveyor belt without any additional rotation.

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further variant of the method provides for automatic insertion machine which is programmable in the x- and y-arrangement and rotational alignment to be used for mounting differently aligned and arranged semiconductor chips on the rewiring substrate strip. This automatic insertion machine picks up arranged and uniformly aligned semiconductor chips from a wafer separated into semiconductor chips or from a foil or conveyor belt uniformly equipped semiconductor chips and applies them to the rewiring substrate strip according to program in accordance with a predetermined arrangement and alignment plan during the equipping of the rewiring substrate strip. Although this variant of the method requires greater expenditure designing and constructing the programmable automatic insertion machine, the semiconductor chips can be provided in standardized manner on a wafer or on a foil in a conveyor belt.

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In a further variant of the method, the semiconductor chips are equipped with flip chip contacts in the component groups. Connections between semiconductor chip and the rewiring substrate strip are established on the top side of the rewiring substrate strip for flip chip contacts by means of a soldering process. Applying semiconductor chips in this manner has the advantage that it may be possible to omit an embedment of the semiconductor chips with flip chip contacts in plastic. In addition, a soldering process is a parallel production step in which a multiplicity of electrical connections can be established at the same time between a rewiring structure of a rewiring substrate strip and flip chip contacts of semiconductor chips.

A further variant of the method provides for semiconductor chips to be mounted with their rear sides on the semiconductor component positions. After that, semiconductor chips connections between the rewiring structure of the rewiring substrate strip are established by means of bonding technology. In this method, contact surfaces on the active top side of the semiconductor chip are connected to corresponding contact pads or bond fingers on the rewiring structure of the rewiring substrate strip by means of bonding wires. This is a serial process in which one bonding connection after another is successively applied and the bonding wires are then embedded in a package compound with the semiconductor chips together and with coverage of the top side of the rewiring substrate strip in order to protect the bonding connections against damage.

To finish the test contact surfaces and/or the external contact patches, they can be selectively plated with a gold alloy. Such selective plating can be carried out by means of vapor deposition or sputtering by

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metallizing the entire surfaces of a component group of a rewiring structure after any patterned photoresist layer has first been applied. After that, the gold layer is removed by lifting or swelling the photoresist on surfaces which are not to be gold-plated. Another possibility consists in providing a metal plating on the substrate strip right from the start, which has a basic metallization, for example of copper, and has a plating of a gold alloy, in order to then pattern this multi-layer metal layer by means of wet etching or plasma removal by means of corresponding photolithographic steps.

If the test surfaces as such are not sufficient for 15 corresponding contacting for the tests planned, solder balls can be soldered to the test contacts in a further variant of the performance of the method, before the tests are to be performed. Contacting the solder balls on the test contact surfaces also has the advantage that the external contact surfaces and/or the external 20 contacts of the product package are protected.

Once a rewiring substrate strip has been produced and tested by means of the method and/or variants of the method described above, the rewiring substrate strip into individual semiconductor can be separated components and then the semiconductor components marked as defective can be sorted out.

In summary, it can be noted that in the substrate strip 30 according to the invention, the space still available within a component group is used for additional test contact surfaces or test contacts. In this arrangement, separate surfaces are provided for the additional test contacts and test contact surfaces directly next to the 35 semiconductor components. This part of the rewiring substrate strip in the form of cutting strips is removed by means of additional cutting lines when the

rewiring substrate strip is separated into individual semiconductor components. The surface which can be additionally used in the cutting strips, is then also second direction extended to a by rotating semiconductor components on the rewiring strip so that the available surface is optimized, e.g. semiconductor the case of components with connections at two edges. The available contact and wiring surface, which can be accessed by the automatic rotating device is enlarged by semiconductor chips and by partially placing contacts or test contact surfaces into the area outside the component group.

The steps of providing cutting strips for test contact surfaces between the component rows and component columns and test contact surfaces outside the component group can be used jointly or separately depending on requirements on the rewiring substrate strips and the measuring technology.

The invention will now be explained in greater detail with reference to the attached figures.

- 25 Figure 1 shows a diagrammatic top view of a rewiring substrate strip according to a first embodiment of the invention,
- Figure 2 shows a basic diagram of an arrangement of test contact surfaces of a component group of a rewiring substrate strip according to a second embodiment of the invention,
- Figure 3 shows a diagrammatic top view of a rewiring substrate strip of the second embodiment of the invention according to figure 2.

Figure 1 shows a diagrammatic top view of a substrate strip 23 of a rewiring substrate strip 100 according to a first embodiment of the invention. The right-hand part of the top view shows a closed plastic cover 17 which covers the area 26 of a component group 5. The details of the component group 5 are shown in the lefthand half of the picture on the rewiring substrate strip 100, the plastic cover 17 having been omitted. In of the first embodiment invention, are arranged under semiconductor components 3 the plastic cover 17. The arrangement is structured three component rows 29 and three component columns 30. The nine semiconductor components 3 are arranged on nine semiconductor component positions 2. The alignment of the semiconductor components 3 in the semiconductor component positions 2 is marked by marking points 7, a distinction having to be made between a first alignment A and an alignment B rotated by 90° with respect to the former.

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Reference symbols 12 identify cutting lines by means of which the rewiring substrate strip 100 is separated into individual semiconductor components 3. Two cutting lines 12 in each case separate cutting strips 18 from the rewiring substrate strip 100. These have test on the rear side 6 which contact surfaces 13 opposite to the top side 31, shown here, of the 100. Ιn the sectional substrate strip at the top right-hand edge enlargement 20 of section of the rear side 6 picture, а semiconductor component position with cutting strip 18 and test contact surfaces 13 which can carry test contacts 19 is shown.

35 The left-hand half of figure 1 shows the component group without the plastic cover 17 and thus exposes a view of the semiconductor chips 4 which have square areas in this embodiment of the invention and can be

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equipped with flip chip contacts. However, each semiconductor component position 2 is rectangular because cutting strip sections are added to the area of the semiconductor chips 4 on two opposite edges 22 of the semiconductor components 3. This rectangular area corresponds to a debugging package while the square area in each of the semiconductor component positions 2 identifies the size of a product package which is produced when the rewiring substrate strip 100 is separated apart along the cutting lines 12.

The area 8 of the cutting strips 18 provides an area for test contact surfaces 13 as can be seen in the sectional enlargement 20 which, however, do not belong to the product package when the rewiring substrate strip 100 is separated. As shown in the sectional enlargement 20, the test contact surfaces 13 on the rear side 6 are used for testing the operability of the semiconductor components 3 or, respectively, of the semiconductor chips 4 without damaging the external contacts 9 of the product package on the rear side 6 of the rewiring substrate strips 100.

The arrangements in the x- and y- direction of a component group 5 as shown on the left-hand half of figure 1 are characterized by the fact that the next neighbors of a semiconductor component arranged in a first alignment A have a second alignment B uniformly rotated by 90° or uniformly rotated by 270°. In the first embodiment of figure 1, test contact surfaces or test contacts are only provided on the cutting strip sections between the product packages and not on the intersection areas 32 of the cutting strips 18.

35 This first embodiment of the invention additionally comprises in an edge area 15 of the rewiring substrate strip 100 a plug-in contact strip 16 which is electrically connected to the test contact surfaces

and/or the external contacts of the component group 5 via a bunch 21 of rewiring lines. This plug-in contact strip 16 is used for providing for temperature cycle tests such as a "burn-in" test simultaneously for one component group 5 in each case. The width b of a cutting strip depends on the number of rows of test contact surfaces 13 which are required for testing the semiconductor chips 4 in the semiconductor component positions.

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In the embodiment according to figure 1, two rows of test contact surfaces 13 are provided on the cutting strips 18 on the rear side 6 of the rewiring substrate strip 100 as is shown in the sectional enlargement 20. 15 sectional enlargement 20 also shows external contacts 9 are arranged on the rear side 6 of rewiring substrate strip 100 in each of the semiconductor component positions 2 in external contact rows 11 and external contact columns 14. Furthermore, the sectional enlargement 20 shows that the entire 20 underside of the product package is covered by external predetermined grid pitch contacts in a with matrix predetermined step size in form. embodiment of the invention, the external contacts 9 25 are solder balls 28 soldered onto external patches 10.

The left-hand half of figure 1 also shows that in the component rows 29 and the component columns 30, first semiconductor chips 4 are in each case arranged with the alignment A on the odd-numbered semiconductor component positions 2, and second semiconductor chips 42 are arranged with the alignment B on even-numbered semiconductor component positions 2. This arrangement of the semiconductor components produces a parallel-rod Parquet pattern for the debugging package where, on the one hand, the square intersection areas 32 with the edge side b are characteristic and, on the other hand,

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the large rectangular areas of the respective associated debugging package characterize the Parquet pattern.

5 Figure 2 shows a basic diagram of an arrangement of test contact surfaces 13 of a component group 5 of a rewiring substrate strip according to a second embodiment of the invention. Components having the same functions as in figure 1 are identified by the same reference symbols and will not be discussed especially.

In this second embodiment, the test contact surfaces 13 are also located on the rear side 6 of a rewiring substrate strip. The test contact surfaces 13 arranged on the cutting strips 18 having the width b. However, the external contour of the debugging package is no longer rectangular but double-T-shaped. shape of the debugging package makes special possible to also exploit the intersection areas 32 of cutting strips 18 for applying test surfaces 13. The test contact surfaces 13 correlated in the intersection areas 32 in such a manner that a quarter of the number of the test contact surfaces 13 in the intersection areas 32 is added to in each case one of the adjacent debugging packages. By this means, the area of the cutting strips is utilized optimally and completely for arranging test contact surfaces. The alignments A and B, which are rotated by 90° to one another, and the alternating arrangement of first semiconductor chips 41 and second semiconductor chips 42 in the component rows 29 and component columns 30 is retained as in the first embodiment.

Figure 3 shows a diagrammatic top view of a rewiring substrate strip 200 of the second embodiment of the invention according to figure 2. Components having the same functions as in the preceding figures are

identified by the same reference symbols and will not be discussed especially.

Figure 3 shows on the left-hand half of the picture, which is shown without plastic cover 17, the changed external contour of the debugging package which makes it possible to also utilize the intersection areas 32 for applying test contacts 13. The first alignment A of first semiconductor chips 41 and the alignment B of the second semiconductor chips 10 remains unchanged. Since the debugging packages per se are not separated, straight cutting lines 12 are also possible along the dashed lines 24 in order to cut square semiconductor components with corresponding 15 external contacts 9 from the rewiring substrate strip 200.